

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Shinji MAEKAWA et al.
Serial No.: 10/827,457
Filed: April 19, 2004
For: Method For Forming Pattern And
Drop Discharge Apparatus
Examiner: Marianne L. Padgett
Art Unit: 1792
Confirmation No.: 2984

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT H (AFTER FINAL)

Applicants have the following response to the Final Rejection of July 23, 2009, a RCE and a one month extension of time being submitted herewith.

Please amend the above-identified application as follows: